

PATENT

In re Application of	:	
	:	
Kiyoshi MAESHIMA	:	
	:	
Serial No.:	:	Group Art Unit:
	:	
Filed: July 17, 2003	:	Examiner:
	:	
For: PHOTO MASK, METHOD OF MANUFACTURING ELECTRONIC DEVICE, AND METHOD OF MANUFACTURING PHOTO MASK	:	

Mail Stop IDS
Commissioner for Patents
P.O. Box 1450
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In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

The relevance of three references listed on attached Form 1449 is discussed in the present specification.

Serial No.:

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.